

Application/Control No.		Applicant(s)/Patent under Reexamination	
	10/803,103	VALVE ET AL.	
	Examiner	Art Unit	
	Qi Han	2626	

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SEARCHED							
Subclass	Date	Examiner					
225	12/11/2007	QH					
226	12/11/2007	QH					
221	12/11/2007	QН					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
·	DATE	EXMR		
Rich Dorvil: priority John Peng: 101-c17, 19-22;102.1-c18 EAST text earch	12/11/2007	QН		
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